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U.S. **UTILITY** Patent Application

PATENT NUMBER and ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GALL	1277	EXAMINER			
10078284	02/15/2002	438	637	2812					
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**APPLICANTS: Vanhaelemeersch Serge; Maex Karen;									
**CONTINUING	G DATA VERIFIED	):	•						
THIS APPLN C	LAIMS BENEFIT	OF 60/26	9,109 02/15/20	001					
** FOREIGN APPLICATIONS VERIFIED:									
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PG-PUB DO N	OT PUBLISH		RESCIN	ID 🗆					
Foreign priority clai		-	no no		ATTO	RNEY DOCKET NO			
35 USC 119 conditions met □ yes □ no Verified and Acknowledged Examiners's intials				IMEC238.001AUS					
TITLE: Method of fabricating a semiconductor device									
					U.S.DEP	T. OF COMM.PAT.8 TM-PTO-435L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED			IMS ALLOW	IS ALLOWED				
,		Assistant Examiner	Total Claims		Print Claim for O.G			
ISSUE FEE			DRAWING					
Amount Due	Date Paid	<b>1</b>	Sheets Drwg.	Figs.Drwg.	Print Fig.			
	<u> </u>	Primary Examiner			1			
TERMINAL		PREPARED FOR ISSUE	Application Examiner					
	DISCLAMER	WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.						
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